



# Thin Film Metrology Seminar, 13-14 June 2023, ACMIN AGH, Cracow - Agenda

### Tuesday, 13 June (Session i)

10:00 - 17:00	Measurements in research groups (Including a break for lunch)	All
18:00 - 21:00	Social event – dinner	All

# Wednesday, 14 June (Session ii)

09:00	Welcome	All
	10 minutes	
	Introduction into spectroscopic ellipsometry – Complex sample analysis in a wide spectral range from DUV to NIR	Sven Peters, SENTECH
09:55	Coffee break	All
	15 mins	
10:10	Live Demo	Alexander Treffer, SENTECH
	60 minutes	
11:10	Ellipsometric measurements of thin oxide films (online)	PhD Zbigniew Starowicz, Photovoltaic Laboratory, IMIM PAS
	15 mins + 5 mins discussion	
11:30	SiOx-TiOy thin films as the material platform for the development of integrated optics devices (online)	PhD, Hab. Cuma Tyszkiewicz, Silesian University of Technology
	15 mins + 5 mins discussion	
11:50	Temperature-dependent spectroscopic ellipsometry of thin polymer films	PhD Barbara Hajduk, CMPW PAS
	15 mins + 5 mins discussion	
12:10	Lunch	All
	60 minutes	





#### Wednesday, 14 June (Session iii)

13:10 Metrical, electrical, and chemical Alexander Treffer, SENTECH

information by FTIR ellipsometry in the infrared spectral range

25 mins + 10 mins discussion

13:45 How to recognise and push limits in Sven Peters, SENTECH

spectroscopic ellipsometry

25 mins + 10 mins discussion

14:20 Coffee break All

#### Wednesday, 14 June (Session iv)

14:40 Spectroscopic ellipsometry and Sven Peters, SENTECH

Mueller matrix ellipsometry for the analysis of anisotropic

materials and 2D periodic structures

(scatterometry)

50 mins + 10 mins discussion

15:40 **Close** All